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CONFIRMATION NO. 9071

SERIAL NUMBER 10/625,407	FILING DATE 07/23/2003 RULE	CLASS 219	GROUP ART UNIT 3742	ATTORNEY DOCKET NO. TWI-8570	
APPLICANTS Michael Duff Howell, Felton, CA; Barry Roy Bowman, Dublin, CA;					
** CONTINUING DATA ***** This application is a CON of 09/859,917 05/17/2001 PAT 6,624,393 which is a DIV of 09/499,478 02/07/2000 PAT 6,261,853 <i>[Signature]</i>					
** FOREIGN APPLICATIONS ***** <i>[Signature]</i>					
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** SMALL ENTITY ** ** 03/23/2004					
Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged <i>[Signature]</i> Initials		STATE OR COUNTRY CA	SHEETS DRAWING 8	TOTAL CLAIMS 8	INDEPENDENT CLAIMS 1
ADDRESS STALLMAN & POLLOCK LLP Suite 290 121 Spear Street San Francisco , CA 94105					
TITLE Method and apparatus for preparing semiconductor wafers for measurement					
FILING FEE RECEIVED 375	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other			

